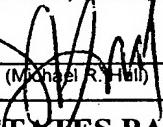


I hereby certify that this correspondence is being deposited with the U.S. Postal Service with sufficient postage as First Class Mail, in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on the date shown below.

Dated: June 10, 2005

Signature: 

(Michael R. Hall)

Docket No.: 29936/39510  
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:  
Young Hee Mun et al.

Application No.: 10/699,438

Confirmation No.: 3273

Filed: October 31, 2003

Art Unit: 2812

For: SILICON WAFER AND METHOD OF  
FABRICATING THE SAME

Examiner: Not Yet Assigned

**SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT (IDS)**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

Pursuant to 37 CFR 1.56, 1.97 and 1.98, the attention of the Patent and Trademark Office is hereby directed to the references listed on the attached PTO/SB/08. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the references be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

This Information Disclosure Statement is filed more than three months after the U.S. filing date and after the mailing date of the first Office Action on the merits, whichever occurs first, but before the mailing date of a Final Office Action or Notice of Allowance (37 CFR 1.97(c)).

I hereby certify that each item of information contained in this Information Disclosure Statement was first cited in any communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of this Information Disclosure Statement.

A copy of each reference on the PTO/SB/08 is attached.

In accordance with 37 CFR 1.97(g), the filing of this Information Disclosure Statement shall not be construed to mean that a search has been made or that no other

material information as defined in 37 CFR 1.56(a) exists. In accordance with 37 CFR 1.97(h), the filing of this Information Disclosure statement shall not be construed to be an admission that any patent, publication or other information referred to therein is "prior art" for this invention unless specifically designated as such.

It is submitted that the Information Disclosure Statement is in compliance with 37 CFR 1.98 and the Examiner is respectfully requested to consider the listed references.

The Director is hereby authorized to charge any deficiency in the fees filed, asserted to be filed or which should have been filed herewith (or with any paper hereafter filed in this application by this firm) to our Deposit Account No. 13-2855, under Order No. 29936/39510. A duplicate copy of this paper is enclosed.

Dated: June 10, 2005

Respectfully submitted,

By \_\_\_\_\_  
Michael R. Hull

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Form PTO-1449 (Modified)

Atty. Docket No.  
29936/39510Serial No.  
10/699,438Applicant(s)  
Young Hee Mun et al.Filing Date  
October 31, 2003Art Unit  
2812**SUPPLEMENTAL INFORMATION  
DISCLOSURE STATEMENT****U.S. PATENT DOCUMENTS**

Examiner Initials	Document Number	Issue or Publication Date	Name	Class	Subclass	Filing Date (If Appropriate)

**FOREIGN PATENT DOCUMENTS**

Examiner Initials	Document Number	Publication Date	Country	Translation Yes	Translation No
	2002-0052565	07-04-2002	Republic of Korea	English Abstract Only	
	2003-0002300	01-08-2003	Republic of Korea	English Abstract Only	✓

**OTHER DOCUMENTS**

Office Action issued by Korean Intellectual Property Office dated May 27, 2005

EXAMINER:

DATE CONSIDERED: